



B EFW

Docket No.: 4733 USA/W-C/W-C/JB1

Patent

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
                            )  
                    Steven Verhaverbeke et al.     )     Examiner:   Markoff, Alexander  
                            )  
Application No:    09/892,130                 )     Art Unit:    1746  
                            )  
Filed: June 25, 2001                              )  
                            )

For: ASSISTED RINSING IN A SINGLE)  
WAFER CLEANING PROCESS)

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.312  
(Amendment After Allowance)

Sir:

In Response to the Notice of Allowance mailed on December 3, 2004, the  
Applicant respectfully requests the Examiner to enter the following amendment.

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FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP \_\_\_\_\_  
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U.S. Patent and Trademark Office, Washington, D.C. 20231 on January 20, 2005 \_\_\_\_\_.

Date of Deposit

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Teresa Mattox

Name of Person Mailing Correspondence

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Signature

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January 20, 2005

Date